

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicants: Kori et al.

Serial No: 09/625,336

Filed: July 25, 2000

PATENT APPLICATION

Group Art Unit Unassigned

Examiner: Unassigned

For: METHOD AND SYSTEM FOR CONTROLLING THE PRESENCE OF
FLUORINE IN REFRACTORY METAL LAYERS

Statement of Alfred W. Mak Under 37 CFR § 1.48(a)

I, ALFRED W. MAK, states as follows:

1. I am over the age of eighteen years and am a co-inventor of the inventions defined by the claims in the above-identified patent application.

2. I make this statement in support of a Petition Under 37 CFR § 1.48(a) which I am informed and believe will be filed herewith to Amend the inventorship of the above-identified patent application to include Ashok Sinha, a citizen of the United States having a residence address of 4176 Hubbart Drive, Palo Alto, California 94306 and Ming Xi, a citizen of the People's Republic of China having a residence address of 138 Beaumere Way, Milpitas, California 95035.

3. The omission of Ashok Sinha and Ming Xi resulted in an error in the inventorship of the above-identified patent application that occurred without any deceptive intent on my part.

Date: 10/30/00

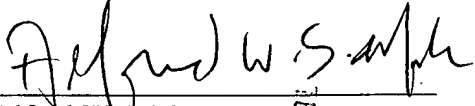

Alfred W. Mak

EXHIBIT B

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